

AMENDMENTS TO THE CLAIMS:

This listing of claims replaces all prior versions and listings of claims in the application:

Listing of Claims:

1. (Currently Amended) A drop ejector, comprising:
a flow path in which fluid is pressurized to eject drops from a nozzle opening in a plane,
and proximate the nozzle opening, a plurality of projections extending ~~transversely to~~ from the
plane of the nozzle opening.
2. (Original) The drop ejector of claim 1 wherein the nozzle opening is surrounded by
projections.
3. (Original) The drop ejector of claim 1 wherein the projections are posts.
4. (Original) The drop ejector of claim 1 wherein the projections are wall-shaped.
5. (Original) The drop ejector of claim 1 wherein the projections are arranged in a pattern.
6. (Original) The drop ejector of claim 5 wherein the pattern defines an array of rows and
columns.
7. (Original) The drop ejector of claim 5 wherein the pattern defines an arc.
8. (Original) The drop ejector of claim 5, wherein the pattern defines concentric ink-collection
spaces.
9. (Original) The drop ejector of claim 1 wherein the projections have a width that is about

twice the nozzle opening width or less.

10. (Currently Amended) The drop ejector of claim 1 ~~wherein the~~further comprising the nozzle opening having a perimeter and a nozzle opening width, wherein~~spacing between the projections are no closer to the perimeter of the nozzle opening than about 20% of the nozzle opening width and the perimeter of the nozzle opening is about 20% of the nozzle opening width or greater.~~

11. (Original) The drop ejector of claim 1 wherein the spacing between projections is about twice the nozzle width or less.

12. (Original) The drop ejector of claim 1 wherein the number of the projections is four or greater.

13. (Original) The drop ejector of claim 1 wherein the height of the projections is substantially equal to the plane of the nozzle opening.

14. (Original) The drop ejector of claim 1 wherein the height of the projections is below the plane of nozzle opening.

15. (Original) The drop ejector of claim 1 wherein the height of the projections is above the plane of the nozzle opening.

16. (Original) The drop ejector of claim 1 wherein the nozzle opening and projections are defined in a common body.

17. (Original) The drop ejector of claim 16 wherein the body is a silicon material.

18. (Original) The drop ejector of claim 1 including a channel proximate the projections.

19. (Original) The drop ejector of claim 1 including a vacuum source or wicking material proximate the projections.

20. (Original) The drop ejector of claim 1 wherein the nozzle opening is disposed in a well and the well includes said projections.

21. (Original) The drop ejector of claim 1 wherein the nozzle opening is disposed on a platform and the projections are disposed proximate the platform.

22. (Currently Amended) The drop ejector of claim 1 including a plurality of nozzle openings and a plurality of projections proximate each of the nozzle openings ~~a plurality of projections~~, said nozzle openings and said projections defined in a common body.

23. (Original) The drop ejector of claim 1 wherein the nozzle opening width is about 200 micron or less.

24. (Original) The drop ejector of claim 1 including a piezoelectric actuator.

25. (Currently Amended) A drop ejector comprising:

a flow path in which fluid is pressurized for ejection through a nozzle opening in a plane, and proximate said nozzle opening, at least four posts extending ~~transversely to~~from the plane of said nozzle opening, said posts and said nozzle opening being defined in a common body.

26. (Original) The drop ejector of claim 25 wherein the spacing between said posts is about 10% of the nozzle opening width or greater and twice the nozzle opening width or less.

27. (Currently Amended) The drop ejector of claim 25 wherein the ~~projections~~posts have a width that is about twice the nozzle opening or less.

28. (Currently Amended) A method of fluid ejection, comprising:

providing a printhead including a flow path in which fluid is pressurized for ejection through a nozzle opening in a plane, and proximate the nozzle opening, a plurality of projections extending ~~transversely to~~from the plane of the nozzle opening, the projections defining a space transverse to the nozzle opening,

providing a fluid that is wicked by capillary forces into the space defined by said projections, and

ejecting said fluid through said nozzle opening by pressurizing said fluid in said flow path.

29. (Original) The method of claim 28 wherein the fluid has a surface tension of about 20-50 dynes/cm.

30. (Original) The method of claim 28 wherein the fluid has a viscosity of about 1 to 40 centipoise.

31. (Currently Amended) A drop ejector, comprising:

a flow path in which fluid is pressurized to eject drops from a nozzle opening in a plane, and proximate the nozzle opening, a plurality of projections extending ~~transversely to~~from the plane of the nozzle opening, wherein the nozzle opening and projections are defined in a common body fabricated from a silicon material and wherein the nozzle opening is disposed on a platform and the projections are disposed proximate the platform.